

<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <i>(Use several sheets if necessary)</i>	<b>Docket Number (Optional)</b> 81864.0057	<b>Application Number</b> 10/529,333
	<b>Applicant</b> Kenya TAKAGAWA et al.	
	<b>Filing Date</b> March 24, 2005	<b>Group Art Unit</b> 1793

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
/CMK/	06-120022	04/28/94	JP			Abstract	
/CMK/	08-169756	07/02/96	JP			Abstract	
/CMK/	10-074612	03/17/98	JP			Abstract	
/CMK/	05-070219	03/23/93	JP			Abstract	
/CMK/	07-315919	12/05/95	JP			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	

<b>EXAMINER</b> /C. Melissa Koslow/	<b>DATE CONSIDERED</b> 03/14/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	